

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18 Stylesheet Version v18.0

> Title of Invention

Method and Device Utilizing Plasma Source for Real-Time **Gas Sampling**

Application Number:

10/038090

Confirmation Number:

5362

First Named Applicant:

Gary Powell

Attorney Docket Number: LTWD 1000-2

Art Unit:

2876

Examiner:

Thien Minh Le

Search string:

(5473162 or 4309187 or 4148612 or

3734631).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	· Cite.No.	Patent No.	Date	Patentee	Kind Class	Subclass
٧	1	5473162	1995-12-05	Busch et al.]	
	2	4309187	1982-01-05	Dodge, III et al.]	
	3	4148612	1979-04-10	Taylor et al.	j '	
W	4	3734631	1973-05-22	Justice et al.	<u> </u>	

Signature

Examiner Name	Date	
LE, THIEN	4/23/04	

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